

On-chip directly phase-modulated laser source for QKD applications

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2018 WORKSHOP PhD STUDENT PROGRESS

Motivation of the work

Indium Phosphide (InP) photonics offers a significant advantage when compared to Silicon Photonics, it allows the integration of active elements. This gives us the ability to add laser sources to Photonic Integrated Circuits (PIC).

This proposal will develop an on-chip directly phase-modulated laser source for Quantum Key Distribution (QKD) applications.

Thesis objectives

- Development of a direct modulation system for a Distributed Bragg Reflector (DBR) laser with random phase modulation for QKD communication systems
- Development of a DBR laser
- Development of the modulator
- Joining together the modulator and laser, manufacturing and characterization

Research plan

	2018	2019	2020
Literature review	■	■	
Design of the photonic directly phase-modulated transmitter prototype	■	■	
Manufacturing and characterization of the transmitter		■	
Design and implementation of interfaces between photonic and RF equipment			■
Experimental results and comparison with theoretical predictions			■

Next year planning

The next year planning includes the following tasks:

- Design of the photonic directly phase-modulated transmitter prototype
- Manufacturing and characterization of the transmitter
- Design and implementation of interfaces between photonic and RF equipment

Results & discussions

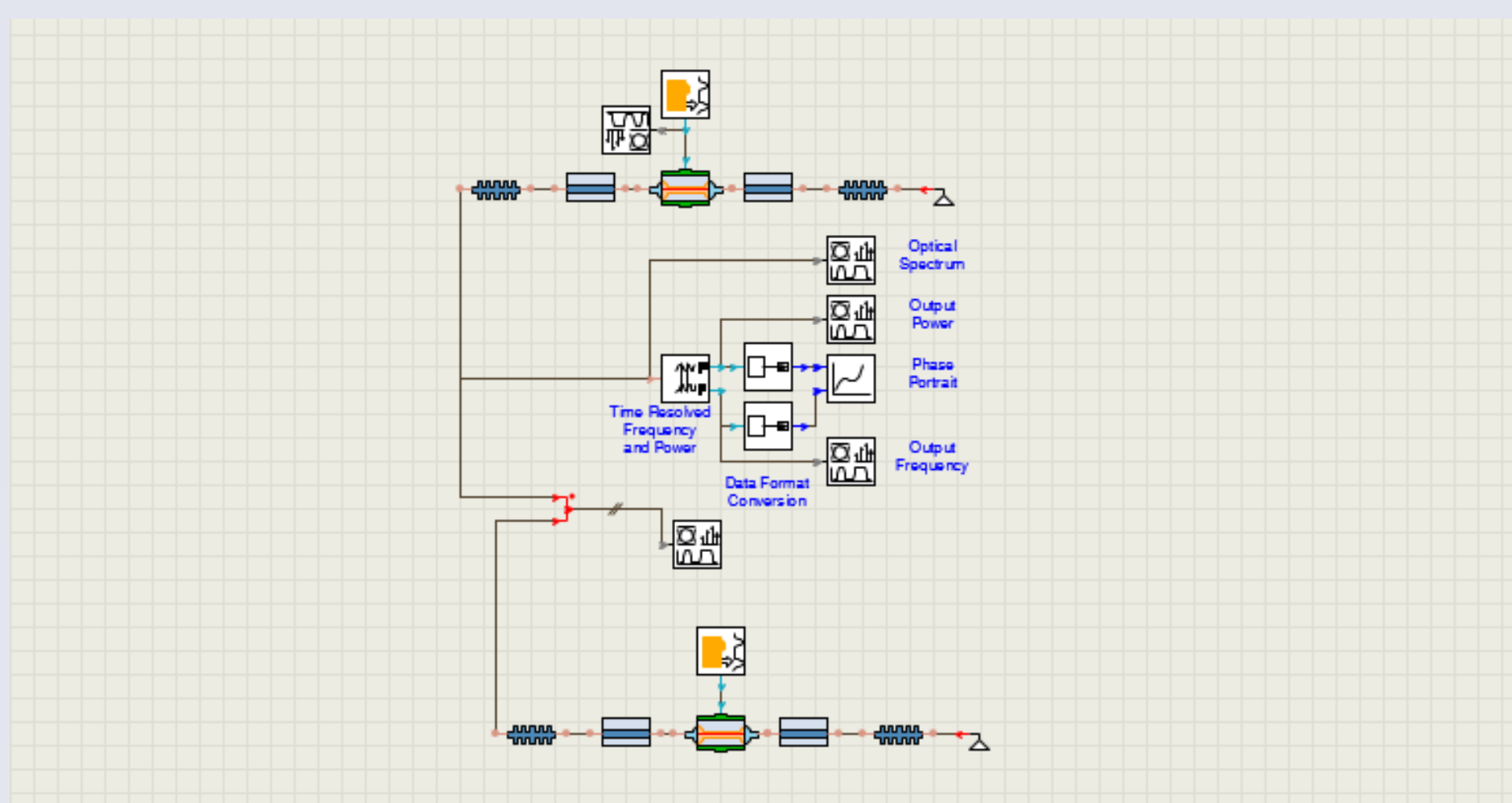


Figure 1. Laser design schematic

The DBR laser is composed by a Semiconductor Optical Amplifier (SOA) and two gratings. The gratings are designed to reflect light at a specific bandwidth. One has is highly reflective and the other has low reflectivity. The parameters of the gratings determine the laser's peak frequency and bandwidth.

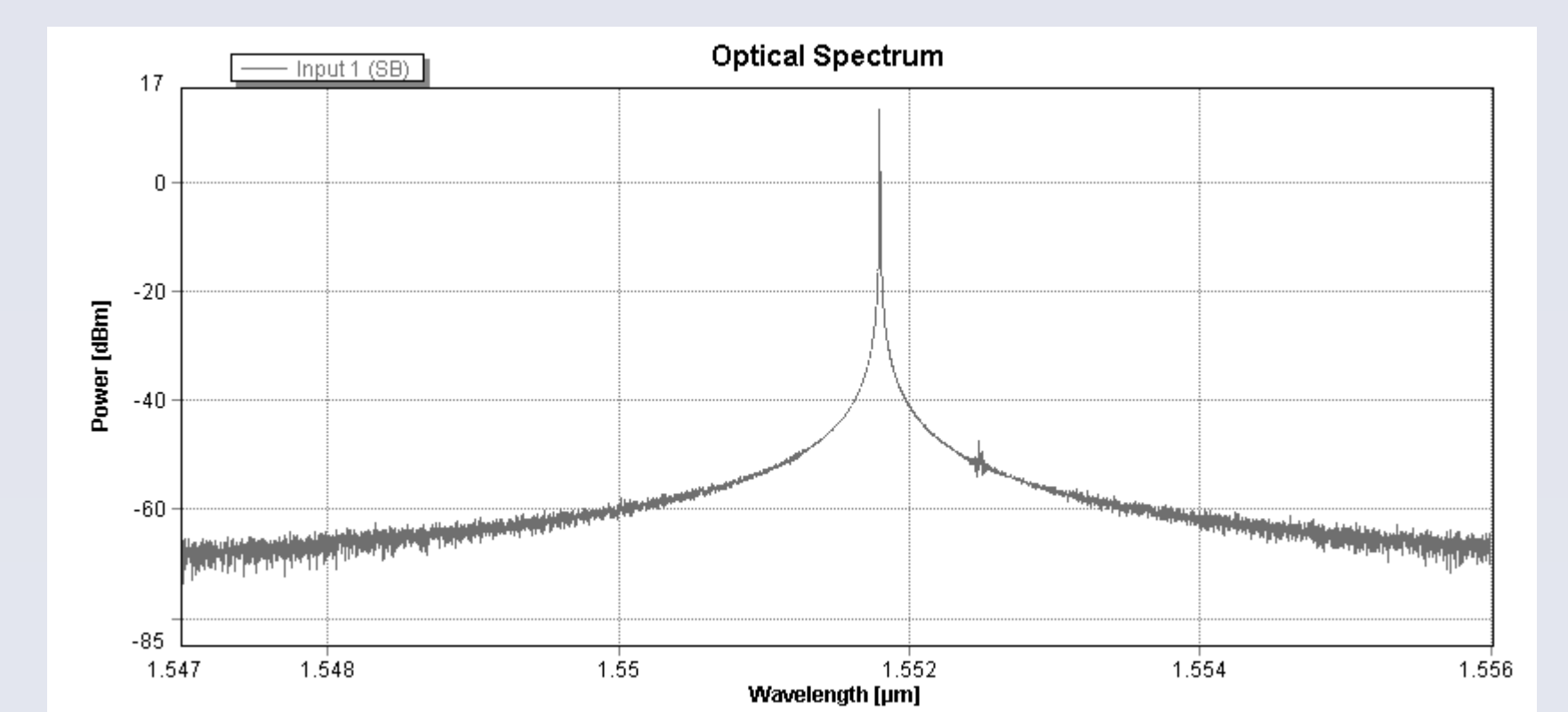


Figure 3. Simulated laser spectrum

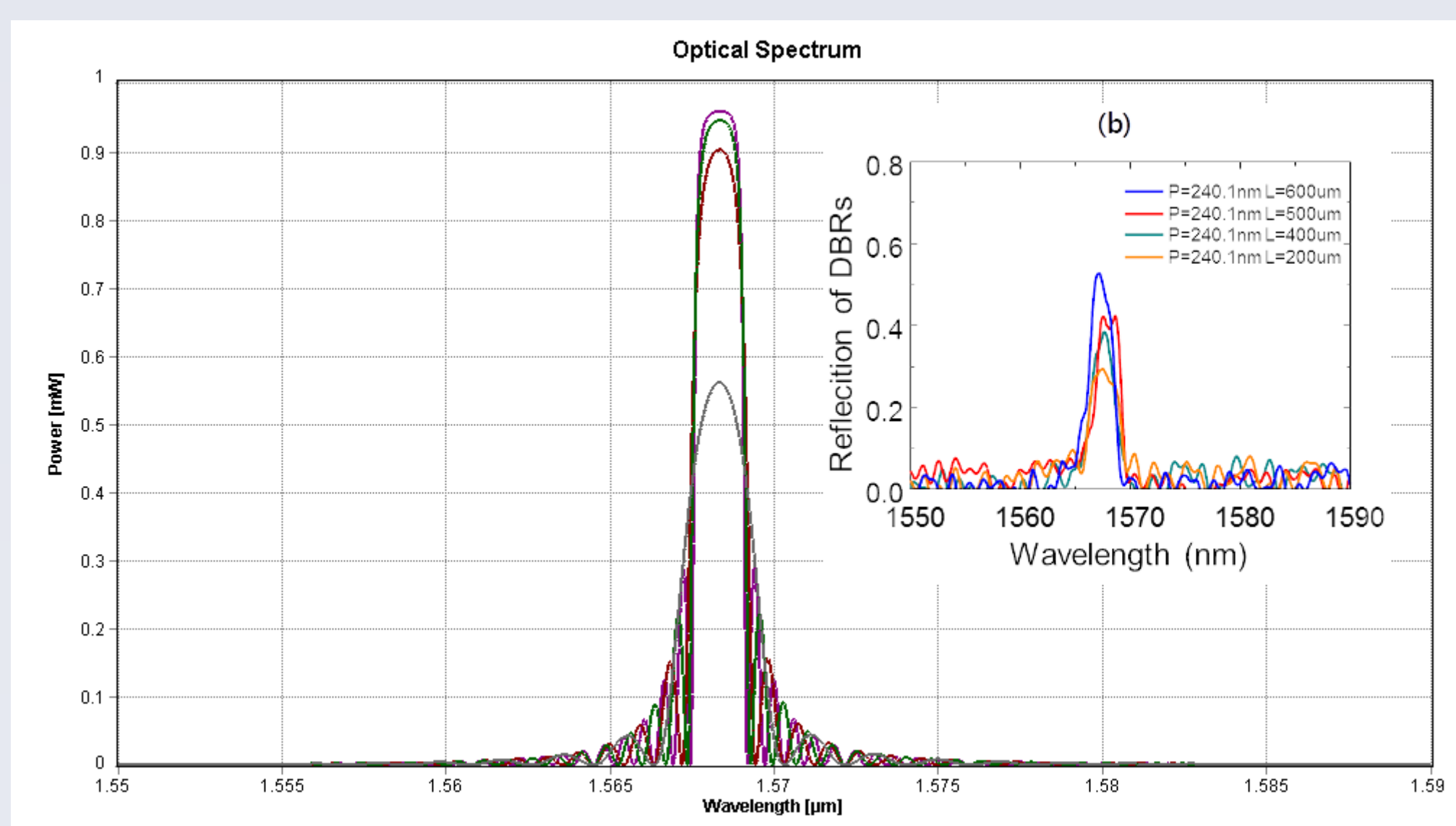


Figure 2. Simulated and measured gratings

The differences between the simulation results and the measured data can be considerable. The differences are caused by changes small in some parameters during manufacturing like, for example, the effective index of the gratings, which shifts the peak frequency significantly.

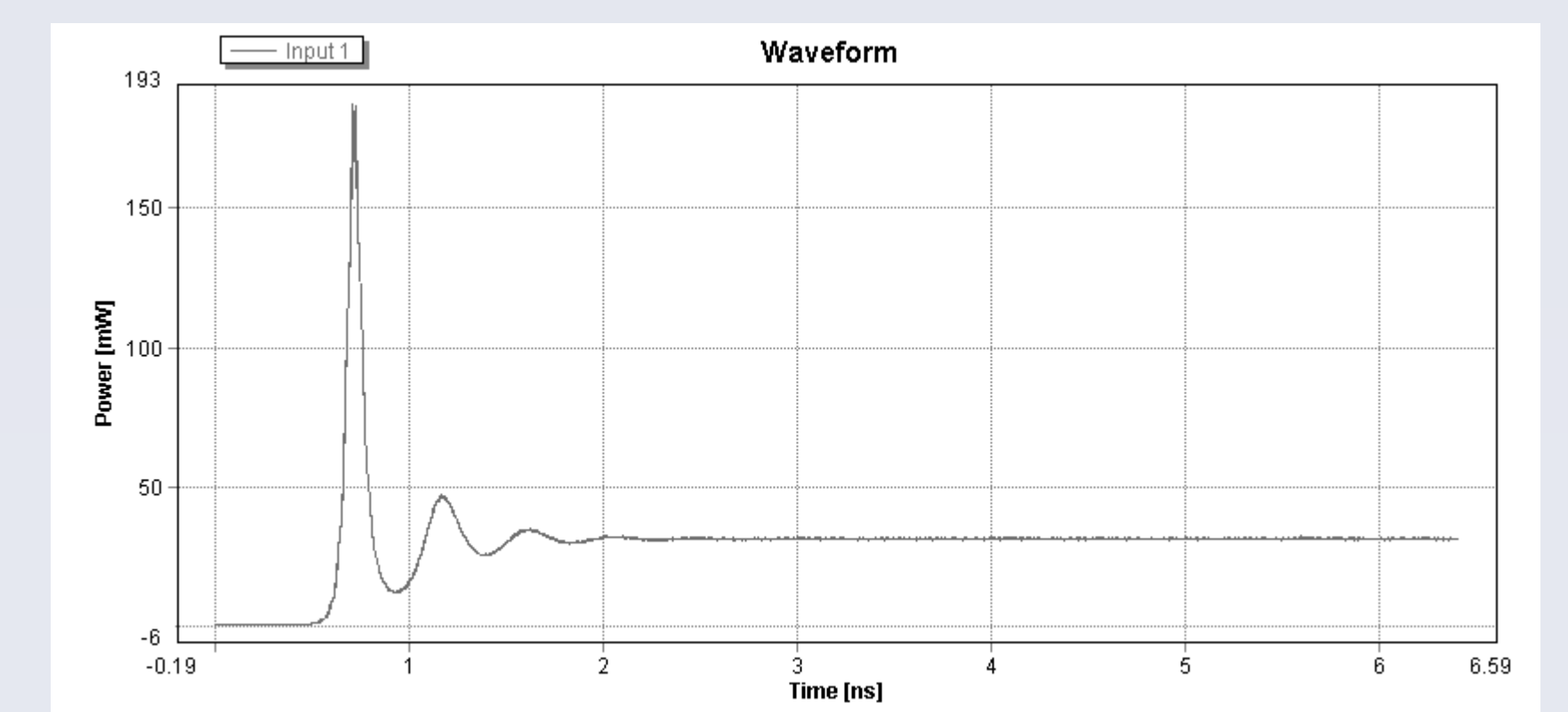


Figure 4. Time domain simulation

References

1. Z. L. Yuan, B. Fröhlich, M. Lucamarini, G. L. Roberts, J. F. Dynes, and A. J. Shields, *Directly Phase-Modulated Light Source*, Phys. Rev. X 6, 031044
2. Zhao, D., Augustin, L. M., Pustakhod, D., Williams, K. A., & Leijtens, X. J. M., *Design of uniform and non-uniform DBR Gratings using transfer-matrix method*, Proceedings of the 20th Annual Symposium of the IEEE Photonics Benelux Chapter, 26-27 November 2015, Brussels, Belgium (pp. 87-90). Brussels: OPERA-photonics, Brussels School of Engineering
3. Zhao, D., Augustin, L. M., Bolk, J., Pustakhod, D., Williams, K. A., & Leijtens, X. J. M., *Distributed Bragg reflectors on InP platform fabricated with deep-UV technology*, Proceedings of the 21st Annual Symposium of the IEEE Photonics Society Benelux Chapter, November 17-18, 2016, Gent, Belgium (pp. 231-234). Gent: Universiteit Gent.